

L Number	Hits	Search Text	DB	Time stamp
1	629	interconnect with narrow	USPAT; US-PGPUB	2002/12/13 12:21
2	417619	semiconductor or IC or "integrated circuit"	USPAT; US-PGPUB	2002/12/13 13:51
3	366	(interconnect with narrow) and (semiconductor or IC or "integrated circuit")	USPAT; US-PGPUB	2002/12/13 12:21
4	1140	interconnect with (narrow or fine)	USPAT; US-PGPUB	2002/12/13 12:21
5	52893	pt	USPAT; US-PGPUB	2002/12/13 12:21
6	101818	platinum	USPAT; US-PGPUB	2002/12/13 12:21
7	136170	pt or platinum	USPAT; US-PGPUB	2002/12/13 12:22
8	117	(interconnect with (narrow or fine)) and (pt or platinum)	USPAT; US-PGPUB	2002/12/13 12:22
9	113088	@ad>20010801 @rlad>20010801	USPAT; US-PGPUB	2002/12/13 12:22
10	102	((interconnect with (narrow or fine)) and (pt or platinum)) not (@ad>20010801 @rlad>20010801)	USPAT; US-PGPUB	2002/12/13 12:35
11	0	".mu.m"	USPAT; US-PGPUB	2002/12/13 12:35
12	0	".mu."	USPAT; US-PGPUB	2002/12/13 13:01
13	40	"cobalt monosilicide"	USPAT; US-PGPUB	2002/12/13 13:03
14	10078	"metal rich" or "metal content"	USPAT; US-PGPUB	2002/12/13 13:04
15	7	"cobalt monosilicide" and ("metal rich" or "metal content")	USPAT; US-PGPUB	2002/12/13 13:50
16	339	(fine or narrow) with (interconnect or "metal line" or "metal lines")	EPO; JPO; DERWENT;	2002/12/13 13:51
17	1109958	semiconductor or IC or "integrated circuit"	IBM_TDB EPO; JPO; DERWENT;	2002/12/13 13:51
18	125	((fine or narrow) with (interconnect or "metal line" or "metal lines")) and (semiconductor or IC or "integrated circuit")	IBM_TDB EPO; JPO; DERWENT;	2002/12/13 13:51
19	941057	pt or platinum	IBM_TDB EPO; JPO; DERWENT;	2002/12/13 13:51
20	15	((((fine or narrow) with (interconnect or "metal line" or "metal lines")) and (semiconductor or IC or "integrated circuit")) and (pt or platinum)	IBM_TDB EPO; JPO; DERWENT;	2002/12/13 13:52